

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| L1 | 3 | "6565962".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 06:01 |
| L2 | 4 | porous adj film with polyimide and conductive adj metal | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 06:02 |
| L3 | 3 | porous adj film with insulating with conductive adj metal | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 06:04 |
| L4 | 14 | porous adj film with conductive adj metal | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 06:05 |
| L5 | 902 | porous adj film with metal\$4 | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 06:05 |
| L6 | 2 | porous adj film with (coated impregnated) with metal\$4 adj layer | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 06:06 |
| L7 | 1 | "200243743" | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 06:14 |
| L8 | 2 | "5510395".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:01 |
| L9 | 0 | porous adj imide and semiconductor | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:01 |
| L10 | 48 | porous adj polyimide and semiconductor | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:30 |
| L11 | 74 | porous adj polyimide and circuit | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:39 |
| L12 | 7 | "987294" | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:40 |

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| L13 | 2 | "5231162".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:42 |
| L14 | 443487 | porous adi polyimide with interlayer | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:42 |
| L15 | 441617 | porous adi polyimide with interlayer with circuit | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:43 |
| L16 | 0 | porous adj polyimide with interlayer with circuit | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:43 |
| L17 | 4 | porous adj polyimide with interlayer | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:43 |
| L18 | 136 | porous adj film with interlayer | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:43 |
| L19 | 24 | porous adj film with interlayer and polyimide | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:47 |
| L20 | 5 | porous adj film with interlayer with substrate and polyimide | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:48 |
| L21 | 3 | porous adj insulating adj film with interlayer with substrate | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:48 |
| L22 | 6 | porous adj insulating adj film with substrate with metal | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:48 |
| L23 | 0 | porous adj insulating adj film with wafer with metal | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:49 |
| L24 | 0 | porous adj insulating adj film same wafer with metal | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:49 |

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| L25 | 23 | porous adj insulating adj film with metal | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2005/10/04 07:49 |
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